## Notice of References Cited Application/Control No. 10/609,366 Examiner David Lee Applicant(s)/Patent Under Reexamination SHIMOMURA ET AL. Art Unit Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-6,650,846	11-2003	Ito, Toshiharu	398/184
*	В	US-2002/0021464	02-2002	Way, David G.	359/124
*	C	US-2002/0131134	09-2002	Hait, John N.	359/181
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	ш	US-			
	F	US-			
	G	US-			
	Н	US-			
	ı	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			

## **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N				-	
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## **NON-PATENT DOCUMENTS**

*	<u> </u>	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	modes as approase, realist, respectively, asiano, a volume, realist, ages/
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.